CHBE320 LECTURE VIII DYNAMIC BEHAVIORS OF CLOSED-LOOP CONTOL SYSTEMS

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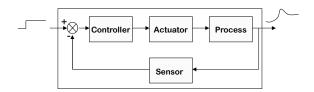
Fall 2021 **Dept. of Chemical and Biological Engineering Korea University**

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Road Map of the Lecture VIII

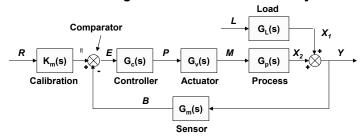
- **Dynamic Behavior of Closed-loop Control System**
 - Closed-loop: controller is connected and working
 - Closed-loop transfer function
 - · Response of output for set point change
 - · Response of output for load/disturbance change
 - Effects of each block on closed-loop system
 - Effect of controller tuning parameters



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BLOCK DIAGRAM REPRESENTATION

Standard block diagram of a feedback control system



- Process TF: MV (M) effect on CV (X2, part of Y)
- Load TF: DV (L) effect on CV (X1, part of Y)
- Sensor TF: CV (Y) is transferred to measurement (B)
- Actuator TF: Controller output (P) is transferred to MV (M)
- Controller TF: Controller output (P) is calculated based on error (E)
- Calibration TF: Gain of sensor TF, used to match the actual var.

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Individual TF of the standard block diagram

- TF of each block between input and output of that block
- Each gain will have different unit.
 - · [Example] Sensor TF
 - Input range: 0-50 l/min
 - · Output range: 4-20 mA



Gain, $K_m = \frac{20 - 4}{50 - 0} = 0.32 \text{ [mA/(l/min)]}$ • Dynamics: usually 1st order with small time constant

- Block diagram shows the flow of signal and the connections
- Schematic diagram shows the physical components connection

- - Electrical signal Pneumatic signal **Temperature Transmitter** Flow Controller Level Indicator

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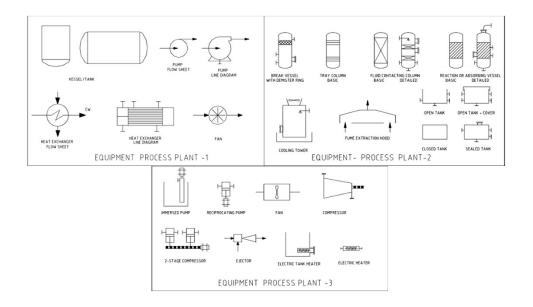
P&ID

Piping and Instrumentation diagram

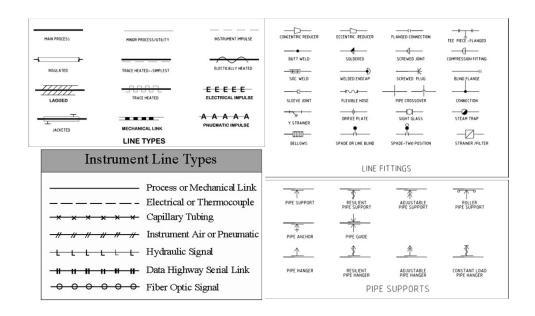
- A P&ID is a blueprint, or map, of a process.
- Technicians use P&IDs the same way an architect uses blueprints.
- A P&ID shows each of the instruments in a process, their functions, their relationship to other components in the system.
- Most diagrams use a standard format, such as the one developed by ISA (Instrumental Society of America) or SAMA (Scientific Apparatus Makers Association).

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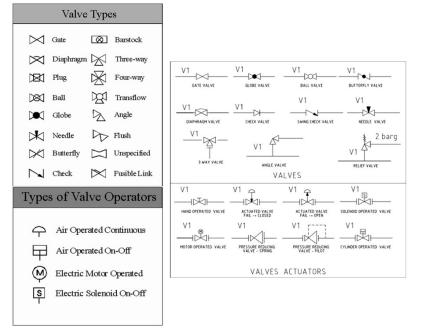


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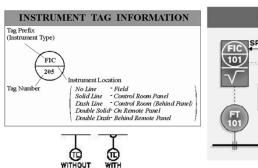
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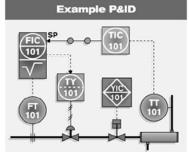


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General instrument or function symbols							
	Primary location accessible to operator	Field mounted	Auxiliary location accessible to operator				
Discrete instruments	`	² O	³				
Shared display, shared control	4	⁵	· E				
Computer function	[′] ⊖	*	, H				
Programmable logic control	10	"\	12				

- Symbol size may vary according to the user's needs and the type of document.
 Abbreviations of the user's choice may be used when necessary to specify location.
 Inaccessible (behind the panel) devices may be depicted using the same symbol but with a dashed horizontal bar. Source: Control Engineering with data from ISA S5.1 standard

Shared display: usually used to indicate video display in DCS Auxiliary location: panel mounted—normally having an analog faceplate

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		Id	entification letters		
	First letter		Succeeding letters		
	Measured or initiating var.	Modifier	Readout or passive func.	Output function	Modifier
Α	Analysis		Alarm		
В	Burner, combustion		User's choice	User's choice	User's choice
С	User's choice			Control	
D	User's choice	Differential			
Е	Voltage		Sensor (primary element)		
F	Flow rate	Ration (fraction)			
G	User's choice		Glass, viewing device		
Н	Hand				High
1	Current (electrical)		Indication		
۲	Power	Scan			
ĸ	Time, time schedule	Time rate of		Control station	
L	Level	change	Light		Low
М	User's choice	Momentary			Middle, interm.
N	User's choice		User's choice	User's choice	User's choice
0	User's choice		Orifice, restriction		
Р	Pressure, vacuum		Point (test connection)		
Q	Quantity	Integrate, totalizer			
R	Radiation		Record		
s	Speed, frequency	Safety		Switch	
т	Temperature	·		Transmit	
U	Multivariable		Multifunction	Multifunction	Multifunction
٧	Vibration, mechanical analysis			Valve, damper, louver	
w	Weight, force		Well		
х	Unclassified	X axis	Unclassified	Unclassified	Unclassified
Υ	Event, state, or presence	Y axis		Relay,compute,convert	
z	Position, dimension	Z axis		Driver, actuator	
Sou	rce: Control Engineering with dat	a from ISA S5.1 stand	ard		•

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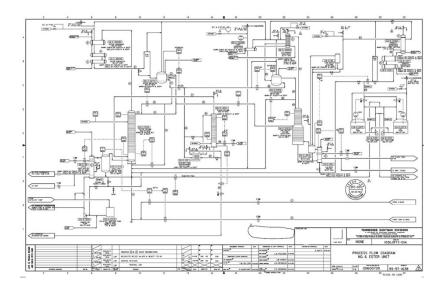
· Instrument description examples

- FIC-101: Flow Indicator and Controller, 0 to 50 m³/Hr, (normal reading 30 T/Hr). This instrument controls the flow of cold feedstock entering the tube side of the heat exchanger by positioning a valve on the cold feedstock flow path.
- FR-103: Flow Recorder, 0 to 10 Ton/Hr, (2.14 T/Hr). This instrument records the steam flow rate.
- HS-101: Hand Switch, ON/OFF (ON). This switch turns on/off cold feedstock pump P-101. When the switch is in the ON condition, the pump is running. When the switch is in the OFF condition, the pump is not running.
- HV-102: Hand Valve, OPEN/CLOSED, (OPEN). This switch opens/closes the steam block valve through which steam is routed from the header to the shell side of the heat exchanger. When the switch is in the OPEN condition the block valve is open. When the switch is in the CLOSED condition, the block valve is closed.
- PAL-103: Pressure Alarm Low, (Normal). This alarm fires should the steam header pressure be less than 6 kg/cm².

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- PI-100: Pressure Indicator, 0 to 15 kg/cm², (3.18 Kg/cm²). This instrument displays the steam pressure at the shell side of the heat exchanger.
- PI-103: Pressure Indicator, 0 to 15 kg/cm², (10.55 Kg/cm²).
 This instrument displays the steam header pressure.
- TAH/L-102: Temperature Alarm High/Low, (Normal). This alarm fires should the temperature of the feedstock at the exchanger outlet exceed 85°C or be less than 71°C.
- TI-103: Temperature Indicator, 0 to 200°C, (186°C). This instrument displays the temperature of the steam entering the shell side of the heat exchanger.
- TIRC-102: Temperature Indicator, Recorder, and Controller, 0 to 200°C, (80°C). This instrument controls the temperature of the feedstock at the exchanger outlet by positioning the valve that regulates the steam flow to the exchanger.
- TR-101: Temperature Recorder, 0 to 200°C, (38°C). This instrument displays the temperature of the feedstock entering the exchanger.

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CLOSED LOOP TRANSFER FUNCTION

Block diagram algebra

Transfer functions of closed-loop system

$$\begin{split} X_2(s) &= G_p(s)G_v(s)G_c(s)E(s) \\ Y(s) &= G_L(s)L(s) + X_2(s) \\ &\Longrightarrow Y(s) = G_L(s)L(s) + G_p(s)G_v(s)G_c(s)E(s) \\ \\ &\Longrightarrow Y(s) = G_L(s)L(s) + G_p(s)G_v(s)G_c(s)(K_m(s)R(s) - G_m(s)Y(s)) \\ \\ &\Longrightarrow (1 + G_m(s)G_p(s)G_v(s)G_c(s))Y(s) = G_L(s)L(s) + K_mG_p(s)G_v(s)G_c(s)R(s) \end{split}$$

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For set-point change (L=0)

$$\frac{Y(s)}{R(s)} = \frac{K_m G_p(s) G_v(s) G_c(s)}{1 + G_m(s) G_p(s) G_v(s) G_c(s)}$$

For load change (R=0)

$$\frac{Y(s)}{L(s)} = \frac{G_L(s)}{1 + G_m(s)G_p(s)G_v(s)G_c(s)}$$

Open-loop transfer function (G_{OL})

$$G_{OL}(s) \triangleq G_m(s)G_p(s)G_v(s)G_c(s)$$

- Feedforward path: Path with no connection backward
- Feedback path: Path with circular connection loop
- GOL: feedback loop is broken before the comparator

Simultaneous change of set point and load

$$Y(s) = \frac{K_m G_p(s) G_v(s) G_c(s)}{1 + G_{oL}(s)} R(s) + \frac{G_L(s)}{1 + G_{oL}(s)} L(s)$$

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MASON'S RULE

· General expression for feedback control systems

$$\frac{Y}{X} = \frac{\pi_f}{1 + \pi_e}$$

 $\pi_f \equiv {
m product}$ of the transfer functions in the path from X to Y $\pi_e \equiv {
m product}$ of all transfer functions in the entire feedback loop

- Assume feedback loop has negative feedback.
- If it has positive feedback, $1 + \pi_e$ should be $1 \pi_e$.
- In the previous example, for set-point change

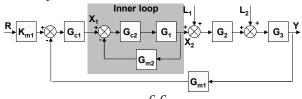
$$\begin{split} X &= R \quad Y = Y \qquad \qquad \pi_f = K_m G_c(s) G_v(s) G_p(s) \qquad \qquad \pi_e = G_{OL}(s) \\ \frac{Y(s)}{R(s)} &= \frac{K_m G_p(s) G_v(s) G_c(s)}{1 + G_{OL}(s)} \end{split}$$

- For load change, X = L Y = Y $\pi_f = G_L(s)$ $\pi_e = G_{OL}(s)$

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Example 1



- Inner loop: $X_2 = \frac{G_1 G_{c2}}{1 + G_{m2} G_1 G_{c2}} X_1$

- TF between R and Y:

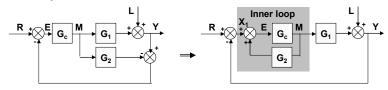
$$\begin{split} \pi_f &= K_{m1}G_3G_2\frac{G_1G_{c2}}{1+G_{m2}G_1G_{c2}}G_{c1} & \pi_e = G_{m1}G_3G_2\frac{G_1G_{c2}}{1+G_{m2}G_1G_{c2}}G_{c1} \\ \frac{Y}{R} &= \frac{K_{m1}G_3G_2G_1G_{c2}G_{c1}}{1+G_{m2}G_1G_{c2}+G_{m1}G_3G_2G_1G_{c2}G_{c1}} \end{split}$$

- TF between L₁ and Y:

$$\frac{Y}{L_1} = \frac{G_3G_2(1+G_{m2}G_1G_{c2})}{1+G_{m2}G_1G_{c2}+G_{m1}G_3G_2G_1G_{c2}G_{c1}}$$

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• Example 2



$$E = R - (G_1 - G_2)M = R - G_1M + G_2M$$

- Inner loop: $M = \frac{G_c}{1 G_2 G_c} X_1$
- TF between R and Y:

$$\pi_f = \frac{G_c}{1 - G_2 G_c} G_1 \qquad \pi_e = \frac{G_c}{1 - G_2 G_c} G_1$$

$$\frac{Y}{R} = \frac{G_1 G_c}{1 - G_2 G_c + G_1 G_c} = \frac{G_1 G_c}{1 + (G_1 - G_2) G_c}$$

- **TF between L and Y:** $\frac{Y}{L} = \frac{1 - G_2 G_c}{1 - G_2 G_c + G_1 G_c} = \frac{1 - G_2 G_c}{1 + (G_1 - G_2) G_c}$

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PID CONTROLLER REVISITED

P control

$$p(t) = \bar{p} + K_c e(t) \xrightarrow{\Omega} \frac{P(s)}{E(s)} = K_c$$

PI control

$$p(t) = \bar{p} + K_c \left\{ e(t) + \frac{1}{\tau_I} \int_0^t e(\tau) d\tau \right\} \xrightarrow{\mathfrak{L}} \frac{P(s)}{E(s)} = K_c (1 + \frac{1}{\tau_I s}) = K_c \frac{(\tau_I s + 1)}{\tau_I s}$$

PID control

$$p(t) = \bar{p} + K_c \left\{ e(t) + \frac{1}{\tau_I} \int_0^t e(\tau) d\tau + \tau_D \frac{de}{dt} \right\} \xrightarrow{\Sigma}$$

$$\frac{P(s)}{E(s)} = K_c (1 + \frac{1}{\tau_I s} + \tau_D s) = K_c \frac{(\tau_I \tau_D s^2 + \tau_I s + 1)}{\tau_I s}$$

- Ideal PID controller: Physically unrealizable
- Modified form has to be used.

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Nonideal PID controller

Interacting type

$$\begin{split} G_c^*(s) &= K_c^* \frac{(\tau_I^* s + 1)}{\tau_I^* s} \frac{(\tau_D^* s + 1)}{(\beta \tau_D^* s + 1)} \underbrace{(0 < \beta \ll 1)}_{\text{Filtering effect}} \\ &- \text{ Comparison with ideal PID except filter} \end{split}$$

$$\begin{split} G_c(s) &= K_c \frac{(\tau_I \tau_D s^2 + \tau_I s + 1)}{\tau_I s} \\ K_c^* \frac{(\tau_D^* \tau_I^* s^2 + (\tau_I^* + \tau_D^*) s + 1)}{\tau_I^* s} &= \frac{K_c^* (\tau_I^* + \tau_D^*)}{\tau_I^*} \left(1 + \frac{1}{(\tau_I^* + \tau_D^*)} \frac{1}{s} + \frac{\tau_D^* \tau_I^*}{(\tau_I^* + \tau_D^*)} s\right) \\ K_c &= \frac{K_c^* (\tau_I^* + \tau_D^*)}{\tau_I^*}, \qquad \tau_I &= \tau_I^* + \tau_D^*, \qquad \tau_D &= \frac{\tau_D^* \tau_I^*}{(\tau_I^* + \tau_D^*)} \end{split}$$

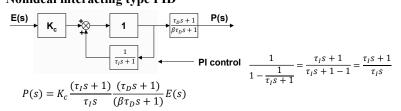
- These types are physically realizable and the modification provides the prefiltering of the error signal.
- Generally, $\tau_I \ge \tau_D$ and typically $\tau_I \approx 4\tau_D$.
- In this form, $\tau_I \ge \tau_D$ is satisfied automatically since algebraic mean is not less than logarithm mean.

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Block diagram of PID controller

- Nonideal interacting type PID



- Removal of derivative kick (PI-D controller)

$$P(s) = K_c \left[\frac{(\tau_I s + 1)}{\tau_I s} R(s) - \frac{(\tau_I s + 1)}{\tau_I s} \frac{(\tau_D s + 1)}{(\beta \tau_D s + 1)} Y(s) \right]$$

- Removal of both P & D kicks (I-PD controller)

$$P(s) = K_c \left[\frac{1}{\tau_I s} R(s) - \frac{(\tau_I s + 1)}{\tau_I s} \frac{(\tau_D s + 1)}{(\beta \tau_D s + 1)} Y(s) \right]$$

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Other variations of PID controller

- Gain scheduling: modifying proportional gain

$$K_c^{GS} = K_c K^{GS}$$

where

$$1.K^{GS} = \begin{cases} K_{Gap} & \text{for (lower gap)} \le e(t) \le (\text{upper gap}) \\ 1 & \text{otherwise} \end{cases}$$

$$2.K^{GS} = 1 + \mathcal{C}_{GS}|e(t)|$$

 $3. K^{GS}$ is decided based on some strategy

- Nonlinear PID controller

- Replace e(t) with e(t) | e(t) |.
- Sign of error will be preserved but small error gets smaller and larger error gets larger.
- It imposes less action for a small error.

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DIGITAL PID CONTROLLER

- Discrete time system
 - Measurements and actions are taken at every sampling interval.
 - An action will be hold during the sampling interval.
- Digital PID controller

$$- \mathbf{using} \qquad \int_{0}^{t_{n}} e(\tau) d\tau = \Delta t \sum_{i=0}^{n} e(t_{i}) \quad \text{(Rectangular rule)}$$

$$\frac{de(t)}{dt} = \frac{e(t_{n}) - e(t_{n-1})}{\Delta t} \quad \text{(Backward difference approx.)}$$

$$p(t_{n}) = \bar{p} + K_{c} \left[e(t_{n}) + \frac{\Delta t}{\tau_{I}} \sum_{i=0}^{n} e(t_{i}) + \tau_{D} \frac{e(t_{n}) - e(t_{n-1})}{\Delta t} \right] \quad \text{(Position form)}$$

$$\Delta p(t_{n}) = p(t_{n}) - p(t_{n-1})$$

$$= K_{c} \left[e(t_{n}) - e(t_{n-1}) + \frac{\Delta t}{\tau_{I}} e(t_{n}) + \tau_{D} \frac{e(t_{n}) - 2e(t_{n-1}) + e(t_{n-2})}{\Delta t} \right] \quad \text{(Velocity form)}$$

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- Most modern PID controllers are manufactured in digital form with short sampling time.
- If the sampling time is small, there is not much difference between continuous and digital forms.
- Velocity form does not have reset windup problem because there is no summation (integration).
- Other approximation such as trapezoidal rule and etc. can be used to enhance the accuracy. But the improvement is not substantial.

$$\begin{split} &\int_0^{t_n} e(\tau) d\tau = \Delta t \sum_{i=1}^n \frac{e(t_i) + e(t_{i-1})}{2} \quad \text{(Trapezoidal rule)} \\ &\frac{de(t)}{dt} = \frac{e(t_n) + 3e(t_{n-1}) - 3e(t_{n-2}) - e(t_{n-3})}{\Delta t} \quad \text{(Interpolation formula)} \end{split}$$

 For discrete time system, z-transform is the counterpart of Laplace transform. (out of scope of this lecture)

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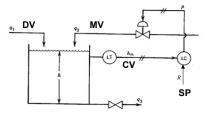
CLOSED-LOOP RESPONSE OF 1ST ORDER SYSTEM

Process

$$\rho A \frac{dh}{dt} = \rho q_1 + \rho q_2 - \rho \frac{h}{R}$$

$$G_p(s) = \frac{H(s)}{Q_2(s)} = \frac{R}{RAs + 1} = \frac{K_p}{\tau s + 1}$$

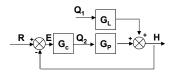
$$G_L(s) = \frac{H(s)}{O_1(s)} = \frac{R}{RAs + 1} = \frac{K_p}{\tau s + 1}$$



- Assume

Sensor and actuator dynamics are fast enough to be ignored and gains are lumped in other TF.

$$\begin{split} G_v(s) &= G_m(s) = 1 \\ H(s) &= \frac{G_c G_p}{1 + G_c G_n} R(s) + \frac{G_L}{1 + G_c G_n} L(s) \end{split}$$



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• P control for set-point change (L=0)

$$G_c(s) = K_c \quad (K_c > 0)$$

$$G_{CL}(s) = \frac{H(s)}{R(s)} = \frac{K_c K_p / (\tau s + 1)}{1 + K_c K_p / (\tau s + 1)} = \frac{K_c K_p / (1 + K_c K_p)}{(\tau / (1 + K_c K_p))s + 1} \text{ (closed-loop TF)}$$

- Closed-loop gain and time constant
$$K_{CL} = \frac{K_c K_p}{(1 + K_c K_p)}, \qquad \tau_{CL} = \frac{\tau}{(1 + K_c K_p)}$$

- Steady-state behavior of closed-loop system

$$K_{CL} = \frac{K_c K_p}{(1 + K_c K_p)} < 1, \qquad \lim_{K_c \to \infty} G_{CL} = 1 \quad (H(s) = R(s), \text{ no offset})$$

$$\text{Steady-state offset} = r(\infty) - h(\infty) = 1 - K_{CL} = \frac{1}{1 + K_c K_p}$$

$$\lim_{K_c \to \infty} G_{CL} = 1 \ (H(s) = R(s), \text{ no offset})$$

Closed-loop response will not reach to set point (offset)

Infinite controller gain will eliminate the offset

Higher controller gain results faster closed-loop response: shorter time constant

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• P control for load change (R=0)

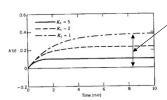
$$G_c(s) = K_c \ (K_c > 0)$$

$$G_{CL}(s) = \frac{H(s)}{L(s)} = \frac{K_p/(\tau s + 1)}{1 + K_c K_p/(\tau s + 1)} = \frac{K_p/(1 + K_c K_p)}{(\tau/(1 + K_c K_p))s + 1} \text{ (closed-loop TF)}$$

- Closed-loop gain and time constant
$$K_{CL} = \frac{K_p}{(1 + K_c K_p)}, \qquad \tau_{CL} = \frac{\tau}{(1 + K_c K_p)}$$

- Steady-state behavior of closed-loop system

$$K_{\mathit{CL}} = \frac{K_p}{(1 + K_c K_p)} > 0, \qquad \quad \lim_{K_c \to \infty} G_{\mathit{CL}} = 0 \ \ (\text{disturbance is compensated})$$



Steady-state offset =
$$0 - h(\infty) = 0 - K_{CL} = -\frac{K_p}{1 + K_c K_p}$$

Disturbance effect will not be eliminated completely (offset)

Infinite controller gain will eliminate the offset

Higher controller gain results faster closed-loop response: shorter time constant

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• PI control for load change (R=0)

$$G_c(s) = K_c(\tau_I s + 1)/\tau_I s \quad (K_c > 0)$$

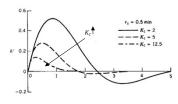
$$G_{CL}(s) = \frac{K_p/(\tau s + 1)}{1 + K_c K_p(\tau_I s + 1)/(\tau s + 1)/\tau_I s} = \frac{K_p \tau_I s}{\tau_I \tau s^2 + \tau_I (1 + K_c K_p) s + K_c K_p}$$

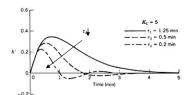
- Closed-loop gain, time constant, damping coefficient

$$K_{num} = \frac{\tau_I}{K_c}, \qquad \tau_{CL} = \sqrt{\frac{\tau \tau_I}{K_c K_p}}, \qquad \zeta_{CL} = \frac{1}{2} \frac{(1 + K_c K_p)}{\sqrt{K_c K_p}} \sqrt{\tau_I/\tau}$$

- Steady-state behavior of closed-loop system

 $\lim_{s \to \infty} G_{CL}(s) = 0$ (disturbance is compensated for all cases)





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- As K_c increases, faster compensation of disturbance and less oscillatory response can be achieved.
- As τ_I decreases, faster compensation of disturbance and less overshooting response can be achieved.
- However, usually the response gets more oscillation as K_c increases or τ_I decreases. => very unusual!!
- If there is small lag in sensor/actuator TF or time delay in process TF, the system becomes higher order and these anomalous results will not occur. These results is only possible for very simple process such as 1st order system.
- Usual effect of PID tuning parameters
 - As K_c increases, the response will be faster, more oscillatory.
 - As τ_I decreases, the response will be faster, more oscillatory.
 - As τ_D increases, the response will be faster, less oscillatory when there is no noise.

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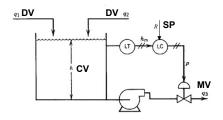
CLOSED-LOOP RESPONSE OF INTEGRATING SYSTEM

Process

$$\rho A \frac{dh}{dt} = \rho(q_1 + q_2) - \rho q_3$$

$$G_p(s) = \frac{H(s)}{Q_3(s)} = -\frac{1}{As}$$

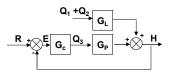
$$G_L(s) = \frac{H(s)}{Q_1(s)} = \frac{1}{As}$$



Assume

Sensor and actuator dynamics are fast enough to be ignored and gains are lumped in other TF.

$$\begin{split} G_v(s) &= G_m(s) = 1 \\ H(s) &= \frac{G_c G_p}{1 + G_c G_p} R(s) + \frac{G_L}{1 + G_c G_p} L(s) \end{split}$$



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• P control for set-point change (L=0)

$$G_c(s) = K_c \quad (K_c < 0)$$

$$G_{CL}(s) = \frac{H(s)}{R(s)} = \frac{K_c/(-As)}{1 + K_c/(-As)} = \frac{1}{(-A/K_c)s + 1} \quad \text{(closed-loop TF)}$$

- Closed-loop gain and time constant

$$K_{CL} = 1,$$
 $\tau_{CL} = -A/K_C$

- Steady-state behavior of closed-loop system

$$K_{CL} = 1$$
 ($H(s) = R(s)$, no offset even with p control)

- It is very unique that the integrating system will not have offset even with P control for the set point change.
- Even though there are other dynamics in sensor or actuator, the offset will not be shown with P control for integrating systems.
- Higher controller gain results faster closed-loop response: shorter time constant

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P control for load change (R=0)

$$G_c(s) = K_c \quad (K_c < 0)$$

$$G_{CL}(s) = \frac{H(s)}{L(s)} = \frac{1/(As)}{1 + K_c/(-As)} = \frac{-1/K_c}{(-A/K_c)s + 1}$$
 (closed-loop TF)

- Closed-loop gain and time constant

$$K_{CL} = (-1/K_c), \qquad \tau_{CL} = -A/K_c$$

- Steady-state behavior of closed-loop system

$$K_{CL} = \frac{1}{(-K_C)} > 0$$
, $\lim_{K_C \to \infty} G_{CL} = 0$ (disturbance is compensated)

- Higher controller gain results faster closed-loop response: shorter time constant

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PI control for set-point change (L=0)

$$G_c(s) = K_c(\tau_I s + 1)/\tau_I s \quad (K_c < 0)$$

$$G_{CL}(s) = \frac{K_c(\tau_I s + 1)/(-As)/\tau_I s}{1 + K_c(\tau_I s + 1)/(-As)/\tau_I s} = \frac{(\tau_I s + 1)}{(-\tau_I A/K_c) s^2 + \tau_I s + 1}$$

- Closed-loop gain, time constant, damping coefficient

$$K_{CL}=1, \qquad au_{CL}=\sqrt{-rac{ au_I A}{K_C}}, \qquad \zeta_{CL}=rac{1}{2}\sqrt{-rac{ au_I K_C}{A}}$$
 — Steady-state behavior of closed-loop system

$$K_{CL} = \lim_{s \to 0} G_{CL}(s) = 1 \ (H(s) = R(s), \text{ no offset})$$

- As (-K_c) increases, closed-loop time constant gets smaller (faster response) and less oscillatory response can be achieved.
- As τ_I decreases, closed-loop time constant gets smaller (faster response) and more oscillatory response can be achieved.
- Partly anomalous results due to integrating nature
- For integrating system, the effect of tuning parameters can be different. Thus, rules of thumb cannot be applied blindly.

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